



DOCKET NO. US010631

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Letavic et al.)	Examiner: Ngo, N.
)	
Application No.: 10/015,640)	Art Unit: 2814
)	
Filed: 12/10/2001)	
)	
For: HIGH FREQUENCY HIGH VOLTAGE)	
SILICON-ON-INSULATOR DEVICE WITH)	
MASK VARIABLE INVERSION CHANNEL)	
AND METHOD FOR FORMING THE SAME)	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

After-Final Amendment

Sir:

Introductory Comments

In response to the Final Office Action of July 31, 2003, please amend the above-identified patent application as follows:

RECEIVED
NOV - 5 2003
TECHNICAL CENTER 2800

SN: 10/015,640